

# SECTION 10—MANUFACTURING AND FABRICATION TECHNOLOGY

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## OVERVIEW

This section describes technologies required for the production of military hardware. In most cases, the technologies, the equipment and the know-how are dual use and impact civil applications where cost, flexibility, competitiveness, etc., have become major concerns. In some cases, these technologies are not state of the art, and the United States is not the world leader in the technology. All countries engaged in the production of military weapons, munitions, and systems possess, to some degree, the know-how in the technology areas indicated in the box above. The level of the technology possessed by a country directly affects the level of military hardware that can be produced and the cost and reliability of the hardware. The concerns of the United States are no longer directed solely at the former technologically advanced Warsaw Pact countries but also at developing countries that are attempting to produce weapons of mass destruction. Therefore, the level of concern for machine tool technology necessary to meet the U.S. anti-proliferation goals is less than that for the state-of-the-art machine tools. Several different technologies, associated with a modern industrial base, are addressed in this section: many types of machine tools for advanced fabrication, production, and processing; certain nondestructive evaluation (NDE) and nondestructive inspection (NDI) equipment; bearings; and certain robots.

## SECTION 10.1—ADVANCED FABRICATION AND PROCESSING

### OVERVIEW

This subsection encompasses two groups of technologies. The first group includes equipment for fabricating structures of various advanced manufacturing techniques: spin, flow, and shear forming machines; superplastic forming/diffusion bonding; high-temperature furnaces and heaters; and stretch forming machines. These technologies involve such actions as bending and/or stretching finished material to form a desired shape or rolling material over mandrels to form curvilinear or cylindrical cross-section parts. The second group includes the development, refinement, and production of nonorganic coatings for nonelectronic substrates. Such substrates include metal, ceramics, various composites, and optical systems. The technologies cover all pertinent coating design features, such as coating formulation, substrate and source material preparation, and post-coating treatments. Of concern are coatings to (1) protect substrate materials from oxidation, hot corrosion, wear, erosion and fatigue; (2) reduce heat input to the substrate; or (3) modify the reflectance or transmittance of the substrate material. For information on related CAD/CAM technology see Section 8.2.

**Table 10.1-1. Advanced Fabrication and Processing Militarily Critical Technology Parameters**

| TECHNOLOGY   | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority  | Critical<br>Materials | Unique Test,<br>Production, and<br>Inspection<br>Equipment | Unique Software<br>and Parameters | Control<br>Regimes           |
|--|--|-----------------------|--|-----------------------------------|------------------------------|
| <b>SPIN, FLOW AND<br/>SHEAR FORMING<br/>MACHINES</b>   | Equipped with numerical or computer controls, containing > 2 axes contouring control and capable of applying a roller force > 60 kN.   | None identified       | None identified  | None identified                   | WA IL Cat 2. NDUL 1.1 MTCR 3 |
| <b>SUPERPLASTIC<br/>FORMING/DIFFUSION<br/>BONDING (SPF/DB)</b>   | Capable of bonding certain alloys (primarily titanium, nickel, aluminum and titanium aluminides) in a single heat cycle.   | None identified       | None identified  | None identified                   | WA IL Cat 2                  |
| <b>VACUUM OR<br/>CONTROLLED<br/>ENVIRONMENT<br/>INDUCTION FURNACES</b>   | Diameter ≥ 600 mm inside the induction coil, Operating at > 850 °C using 0.5 kW power supplies   | None identified       | None identified  | None identified                   | NDUL 1.4                     |
| <b>VACUUM OR<br/>CONTROLLED<br/>ATMOSPHERE<br/>METALLURGICAL<br/>MELTING AND<br/>CASTING FURNACES</b>          | Arc melt and casting furnaces with consumable electrode capacities >1,000 cm <sup>3</sup> and < 20,000 cm <sup>3</sup> and operating at temp >1,700 °C. Electron beam melting and plasma atomization and melting furnaces with power ≥ 50 kW and temperature >1,200 °C | None identified       | None identified  | None identified                   | NDUL 1.8                     |
| <b>CHEMICAL VAPOUR<br/>DEPOSITION (CVD)<br/>EQUIPMENT</b>  | High vacuum rotating seals (≤ 0.01 Pa) or <i>in situ</i> coating thickness control.  | None identified       | None identified  | None identified                   | WA IL Cat 1, 2 MTCR 7        |
| <b>ION IMPLANTATION<br/>PRODUCTION<br/>EQUIPMENT</b>   | Beam current ≥ 5 mA  | None identified       | None identified  | None identified                   | WA IL Cat 2                  |
| <b>ION ASSISTED<br/>RESISTIVE HEATING<br/>VAPOUR DEPOSITION<br/>(ION PLATING)<br/>PRODUCTION<br/>EQUIPMENT</b> | Vacuum of 10 <sup>-3</sup> torr, or better, A substrate to plasma potential of 15 to 20 V and An overall capability to deposit film with a uniformity of ± 1.0 percent over the substrate surface.   | None identified       | None identified  | None identified                   | WA IL Cat 2                  |

(Continued)

**Table 10.1-1. Advanced Fabrication and Processing Militarily Critical Technology Parameters (Continued)**

| TECHNOLOGY   | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority   | Critical<br>Materials | Unique Test,<br>Production, and<br>Inspection<br>Equipment                          | Unique Software<br>and Parameters | Control<br>Regimes              |
|--|---|-----------------------|---|-----------------------------------|---------------------------------|
| <b>PLASMA SPRAY<br/>EQUIPMENT</b>  | Either operation at reduced pressure controlled atmosphere ( $\leq 10$ kPa measured above and within 300 mm of gun nozzle) in a vacuum chamber capable of 0.01 Pa; <u>or</u> Incorporating in situ coating thickness control. | None identified       | None identified   | None identified                   | WA IL Cat 2                     |
| <b>SPUTTER DEPOSITION<br/>EQUIPMENT</b>  | Capable of current densities $\geq 0.1$ mA/mm <sup>2</sup> at a deposition rate $\geq 15$ $\mu$ m/hr.   | None identified       | None identified   | None identified                   | WA IL Cat 2                     |
| <b>THERMAL SPRAY<br/>FORMING EQUIPMENT</b>   | Power levels > 150 kW,<br>Gas velocities of 3,000 m/s and<br>Spray rates of > 15 kg/h.  | None identified       | Digitally controlled atomization of molten metal and automatic rastering of mandrel | None identified                   | None                            |
| <b>SPIN, FLOW AND<br/>SHEAR FORMING<br/>MACHINES</b>   | Equipped with numerical or computer controls, containing > 2 axes contouring control and capable of applying a roller force > 60 kN.  | None identified       | None identified   | None identified                   | WA IL Cat 2. NDUL 1.1<br>MTCR 3 |
| <b>SUPERPLASTIC<br/>FORMING/DIFFUSION<br/>BONDING (SPF/DB)</b>   | Capable of bonding certain alloys (primarily titanium, nickel, aluminum and titanium aluminides) in a single heat cycle.  | None identified       | None identified   | None identified                   | WA IL Cat 2                     |
| <b>VACUUM OR<br/>CONTROLLED<br/>ENVIRONMENT<br/>INDUCTION FURNACES</b>   | Diameter $\geq 600$ mm inside the induction coil,<br>Operating at > 850 °C using 0.5 kW power supplies  | None identified       | None identified   | None identified                   | NDUL 1.4                        |
| <b>METROLOGY<br/>EQUIPMENT FOR<br/>SPECTRAL<br/>CHARACTERIZATION<br/>OF REFLECTANCE,<br/>TRANSMISSION,<br/>ABSORPTION AND<br/>SCATTER.</b> | Capable of measuring reflectance/transmission to better than 1 part in 1,000 absolute accuracy or Absorption/scatter to better than 1 part in 100,000.  | None identified       | None identified   | None identified                   | None                            |
| <b>SINGLE CRYSTAL<br/>ALLOY CASTING<br/>EQUIPMENT</b>  | Capable of producing cooled turbine blades with stress rupture life exceeding 400 hours at 1273 K (1,000 °C) at a stress of 200 MPa   | None identified       | None identified   | None identified                   | WA IL Cat 9                     |
| <b>COMPOSITE<br/>FILAMENT WINDING<br/>EQUIPMENT</b>  | Three or more coordinated axes.   | None identified       | None identified   | None identified                   | WA IL Cat 1<br>MTCR 6           |
| <b>COMPOSITE TAPE<br/>LAYING EQUIPMENT</b>   | Two or more coordinated axes.   | None identified       | None identified   | None identified                   | WA IL Cat 1<br>MTCR 6           |
| <b>COMPOSITE WEAVING<br/>OR INTERLACING<br/>EQUIPMENT</b>  | Ability to perform multi-directional and multi-dimensional weaving or interlacing.  | None identified       | None identified   | None identified                   | WA IL Cat 1<br>MTCR 6           |
| <b>EQUIPMENT FOR<br/>PRODUCING PREPEGS<br/>BY THE HOT MELT<br/>METHOD</b>  | Ability to manufacture prepegs with a specific tensile strength > $17 \times 10^4$ m and<br>A specific modulus > $10 \times 10^6$ m or<br>A melting, softening or sublimation point > 1,922 K (1,649 °C).                     | None identified       | None identified   | None identified                   | WA IL Cat 1                     |

(Continued)

**Table 10.1-1. Advanced Fabrication and Processing Militarily Critical Technology Parameters (Continued)**

| TECHNOLOGY  | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority   | Critical<br>Materials                            | Unique Test,<br>Production, and<br>Inspection<br>Equipment   | Unique Software<br>and Parameters | Control<br>Regimes    |
|---|---|--|--|-----------------------------------|-----------------------|
| EQUIPMENT TO<br>MANUFACTURE<br>FIBERS   | Capable of converting polymeric fibers (such as polyacrylonitrile, rayon, pitch, or polycarbosilane) into carbon fibers or silicon carbide fibers.                                      | None identified                                  | None identified  | None identified                   | WA IL Cat 1           |
| SYSTEMS SPECIALLY<br>DESIGNED TO<br>PREVENT<br>CONTAMINATION IN<br>THE PRODUCTION OF<br>METAL ALLOYS AND<br>METAL POWDERS.  | Capable of maintaining a contamination level < 3 non-metallic particles larger than 100 microns in 10 <sup>9</sup> alloy particles (for nickel).  | None identified                                  | None identified  | None identified                   | WA IL Cat 1           |
| EQUIPMENT FOR THE<br>MANUFACTURE OF<br>MICROMECHANICAL<br>DEVICES, INCLUDING<br>LITHOGRAPHY<br>EQUIPMENT,<br>ELECTRON AND ION<br>BEAM MILLING-<br>ETCHING-GRINDING-<br>POLISHING MACHINES,<br>CHEMICAL VAPOUR<br>DEPOSITION AND<br>ETCHING EQUIPMENT. | Ability to manufacture micromechanical devices with dimensions ≤1 micron.   | None identified                                  | Material removal and assembly equipment including lithography, electron and ion beam milling, grinding, etching, polishing, chemical vapor deposition and etching; and tooling and fixturing | None identified                   | WA IL Cat 2., 3       |
| DEEP HOLE DRILLING<br>MACHINES  | Computer controlled and having a maximum depth-of-bore > 5,000 mm.  | None identified                                  | None identified  | None identified                   | WA IL Cat 2           |
| CHEMICAL VAPOUR<br>DEPOSITION (CVD)   | High vacuum rotating seals (≤ 0.01 Pa) or In situ coating thickness control.  | None identified                                  | None identified  | None identified                   | WA IL Cat 2<br>MTCR 7 |
| ION IMPLANTATION<br>PRODUCTION  | Beam current ≥ 5 ma   | None identified                                  | None identified  | None identified                   | WA IL Cat 2           |
| ION ASSISTED<br>RESISTIVE HEATING<br>VAPOUR DEPOSITION<br>(ION PLATING)<br>PRODUCTION   | Vacuum of 10 <sup>-7</sup> torr, or better, An ion source acceleration voltage of 5 to 40 kV, and A current density of > 30 mA.   | None identified                                  | None identified  | None identified                   | WA IL Cat 2           |
| PLASMA SPRAY  | Operation at reduced pressure controlled atmosphere (≤ 10 kPa) in a vacuum chamber capable of 0.01 Pa; <u>or</u> Incorporating in situ coating thickness control.                       | None identified                                  | None identified  | None identified                   | WA IL Cat 2           |
| SPUTTER DEPOSITION  | Capable of current densities ≥ 0.1 mA/mm <sup>2</sup> at a deposition rate ≥ 15 μm/hr.  | None identified                                  | None identified  | None identified                   | WA IL Cat 2           |
| PYROLYTIC<br>DEPOSITION   | Ability to produce pyrolytically derived materials (e.g., pyrolytic graphite), from precursor gases which decompose in the 1300° to 2900 °C range, at pressures of 1 mm Hg to 150 mmHg. | None identified                                  | None identified  | None identified                   | MTCR 7                |
| HIGH TEMPERATURE<br>PROTECTION<br>COATINGS FOR<br>ENGINE PARTS  | Reduce temperature of underlying layer by 150° C, or greater.   | ZrO <sub>2</sub> + Y <sub>2</sub> O <sub>3</sub> | None identified  | None identified                   | WA IL Cat 2           |

(Continued)

**Table 10.1-1. Advanced Fabrication and Processing Militarily Critical Technology Parameters (Continued)**

| TECHNOLOGY  | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority                                 | Critical<br>Materials                           | Unique Test,<br>Production, and<br>Inspection<br>Equipment | Unique Software<br>and Parameters | Control<br>Regimes |
|---|---|---|--|-----------------------------------|--------------------|
| HIGH TEMPERATURE<br>PROTECTION<br>COATINGS FOR<br>ENGINE PARTS  | Allow operation at 2,000 °C.  | Silicides                                       | None identified  | None identified                   | WA IL Cat 2        |
| HIGH TEMPERATURE<br>PROTECTION<br>COATINGS FOR<br>ENGINE PARTS  | Allow operation at 2,000 °C and<br>resists erosion.   | Ceramics;<br>e.g.<br>alumina<br>and<br>magnesia | None identified  | None identified                   | WA IL Cat 2        |
| INCREASED WEAR<br>COATINGS FOR<br>ENGINES, DOMES AND<br>WINDOWS | Hardness $\geq 9,000$ kg/mm <sup>2</sup>  | Cr  | None identified  | None identified                   | WA IL Cat 2        |
| INCREASED WEAR<br>COATINGS FOR<br>BEARINGS                      | Increase of 300% in surface hardness,<br>with concurrent reduction in sliding<br>friction by a factor of 3. | AU, Pt, Ir,<br>Ta, C, N2<br>and B               | None identified  | None identified                   | WA IL Cat 2        |
| OPTICAL COATINGS<br>FOR GUIDANCE<br>SYSTEMS                     | Anti-reflection films and resists rain,<br>sand and oxidation at temperatures<br>> 700 °C.                  | IR coatings;<br>e.g., SnS<br>and ZnSe           | None identified  | None identified                   | WA IL Cat 2        |
| OPTICAL COATINGS<br>FOR SENSORS                                 | Filters, with selectable or variable<br>bandpass in 0.2 to 20 micron spectral<br>range.                     | Oxides,<br>fluorides<br>and sulfides            | None identified  | None identified                   | WA IL Cat 2        |
| STEALTH COATINGS<br>FOR SIGNATURE<br>REDUCTION                  | Signature reduction   | Polymers<br>and organic<br>matrix<br>composites | None identified  | None identified                   | WA IL Cat 2        |

## SECTION 10.2—BEARINGS

### OVERVIEW

This subsection covers various types of bearings and the technology required for their development and manufacture. Bearing types have proliferated as the applications for their use have developed, particularly in advanced machines where the relative motion between two parts must occur smoothly, quietly, and reliably and with a long time between failures. In general, bearings can be categorized as either sliding surface, rolling element, or magnetic. Sliding bearings may incorporate self-lubricating materials or introduce a lubricant between the moving parts. When load capacity is obtained because of the dynamic motion within the bearing, it is known as a hydrodynamic bearing. Rolling bearings, however, may use either balls, cylindrical rollers, tapered rollers, spherical rollers, or needle roller elements. The lubricant, bearing design, materials, and operating environment are usually important parameters in the development of a thin lubricant film between the rolling elements and the mating surfaces within the bearing. Magnetic bearings are manufactured using magnetic materials and operate in a mode in which the surfaces do not physically slide or roll on each other but are separated by the strength of the magnetic field.

Bearings addressed in this subsection include the following types:

- Sliding bearings - fluid film, gas film, and fabric-lined
- Rolling element bearings - precision, hostile environment element anti-friction, low-torque anti-friction, and extreme precision
- Magnetic bearings - active.

**Table 10.2-1. Bearings Militarily Critical Technology Parameters**

| TECHNOLOGY  | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority   | Critical Materials   | Unique Test,<br>Production, and<br>Inspection<br>Equipment   | Unique Software<br>and Parameters | Control<br>Regimes |
|---|---|--|--|-----------------------------------|--------------------|
| <b>BEARING, BALL<br/>OR SOLID<br/>ROLLER, EXCEPT<br/>TAPERED.</b> | Manufactured for use in a radioactive environment at temperatures > 300 °C either by use of special materials or by special heat treatment. | Tungsten carbide, synthetic sapphire, Monel, beryllium, M50 NiL steel, Stellite, Inconel, beryllium copper or silicon nitride. | Grinding, lapping and honing machines and fixtures; gaging and metrology equipment for curved geometry measurement to 1 μ inch accuracy. | None identified                   | WA IL Cat 2        |
| <b>BEARING, BALL<br/>OR SOLID<br/>ROLLER, EXCEPT<br/>TAPERED.</b> | Having lubrication elements or modifications that enable operation at speeds > 2.3 million DN.  | Tungsten carbide, synthetic sapphire, Monel, beryllium, M50 NiL steel, Stellite, Inconel, beryllium copper or silicon nitride. | Grinding, lapping and honing machines and fixtures; gaging and metrology equipment for curved geometry measurement to 1 μ inch accuracy. | None identified                   | WA IL Cat 2        |

(Continued)

**Table 10.2-1. Bearings Militarily Critical Technology Parameters (Continued)**

| TECHNOLOGY  | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority  | Critical Materials   | Unique Test,<br>Production, and<br>Inspection<br>Equipment   | Unique Software<br>and Parameters | Control<br>Regimes |
|---|--|--|--|-----------------------------------|--------------------|
| <b>BEARING, BALL<br/>OR SOLID<br/>ROLLER, EXCEPT<br/>TAPERED.</b> | For 0.5 inch-pitch-diameter bearings with $5 \times 10^{-4}$ radial play, operate at slow speed (1–4 RPM) 400 gram thrust load friction torque < 0.6 gm cm;<br>For other sizes, loads or clearances, a starting torque < 4,500 milligm-mm. | Tungsten carbide, synthetic sapphire, Monel, beryllium, M50 NiL steel, Stellite, Inconel, beryllium copper or silicon nitride. | Grinding, lapping and honing machines and fixtures; gaging and metrology equipment for curved geometry measurement to 1 $\mu$ inch accuracy. | None identified                   | WA IL Cat 2        |
| <b>BEARINGS,<br/>PRECISION BALL</b>                               | Having tolerances of ABEC 9, ABEC 9P, ISO Standard Class 2 or 2A, or better.   | Tungsten carbide, synthetic sapphire, Monel, beryllium, M50 NiL steel, Stellite, Inconel, beryllium copper or silicon nitride. | Grinding, lapping and honing machines and fixtures; gaging and metrology equipment for curved geometry measurement to 1 $\mu$ inch accuracy. | None identified                   | WA IL Cat 2        |
| <b>BEARINGS, SOLID<br/>TAPERED ROLLER</b>                         | Having tolerances of ANSI/AFBMA/ISO Class 0 inch or ANSI/AFBMA Class B/ISO Class 4, or better, with lubrication elements allowing speeds > 2.3 million DN and a fracture toughness of 45 ksi square root inches.                           | Manufactured from M50 NiL steel, or silicon nitride, with lubrication elements allowing speeds > 2.3 million DN.               | Grinding, lapping and honing machines and fixtures; gaging and metrology equipment for curved geometry measurement to 1 $\mu$ inch accuracy. | None identified                   | None               |
| <b>BEARINGS, SOLID<br/>TAPERED ROLLER</b>                         | Having tolerances of ANSI/AFBMA/ISO Class 0 inch or ANSI/AFBMA Class B/ISO Class 4, or better, for operation at temperatures < – 54 °C or > 150 °C and having a fracture toughness of 45 ksi square root inches.                           | M50 NiL steel, or silicon nitride, for operation at temperatures < – 54 °C or > 150 °C.  | Grinding, lapping and honing machines and fixtures; gaging and metrology equipment for curved geometry measurement to 1 $\mu$ inch accuracy. | None identified                   | None               |
| <b>BEARINGS,<br/>NEEDLE ROLLER</b>                                | Having a fracture toughness of 45 ksi square root inches.  | M50 NiL steel.   | Grinding, lapping and honing machines and fixtures; gaging and metrology equipment for curved geometry measurement to 1 $\mu$ inch accuracy  | None identified                   | None               |
| <b>BEARINGS, GAS-<br/>LUBRICATED FOIL</b>                         | Operation at temperatures > 288 °C and a unit load capacity > 15 psi (0–1 MPa) and,<br>In machine tools, permits runouts of 0.0004 mm (about 1/2 that of precision rolling bearings).  | Gas; e.g., helium.   | Grinding, lapping and honing machines and fixtures; gaging and metrology equipment for curved geometry measurement to 1 $\mu$ inch accuracy  | None identified                   | None               |

(Continued)

**Table 10.2-1. Bearings Militarily Critical Technology Parameters (Continued)**

| TECHNOLOGY                           | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority           | Critical Materials   | Unique Test,<br>Production, and<br>Inspection<br>Equipment  | Unique Software<br>and Parameters | Control<br>Regimes |
|--------------------------------------|---|--|---|-----------------------------------|--------------------|
| <b>BEARINGS,<br/>ACTIVE MAGNETIC</b> | Having flux densities of<br>2.0 teslas, or greater, and<br>Yield strengths > 414 MPa. | High-saturation flux-<br>density magnetic<br>materials; e.g.,<br>Vanadium<br>Permandur, Hiperco<br>27.           | Grinding, lapping<br>and honing<br>machines and<br>fixtures; gaging and<br>metrology<br>equipment for<br>curved geometry<br>measurement to<br>1 $\mu$ inch accuracy | None identified                   | WA IL Cat<br>2     |
| <b>BEARINGS,<br/>ACTIVE MAGNETIC</b> | Having all electromagnetic<br>3D homopolar bias designs<br>for actuators              | Magnetic materials<br>with load carrying<br>capacities<br>> 70 psi and rare-<br>earth high density<br>materials. | Grinding, lapping<br>and honing<br>machines and<br>fixtures; gaging and<br>metrology<br>equipment for<br>curved geometry<br>measurement to<br>1 $\mu$ inch accuracy | None identified                   | WA IL Cat<br>2     |
| <b>BEARINGS,<br/>ACTIVE MAGNETIC</b> | Having position sensors<br>capable of operation at<br>temperatures > 177 °C.          | Magnetic materials<br>with load carrying<br>capacities<br>> 70 psi and rare-<br>earth high density<br>materials. | Grinding, lapping<br>and honing<br>machines and<br>fixtures; gaging and<br>metrology<br>equipment for<br>curved geometry<br>measurement to<br>1 $\mu$ inch accuracy | None identified                   | WA IL Cat<br>2     |



## SECTION 10.3—METROLOGY

### OVERVIEW

This subsection covers technology for dimensional measuring systems and equipment needed for precise determination of the dimensions of manufactured parts, machine tools, and inspection machines. Included are systems for in-process measurement and post-manufacture inspection. This technology area is of paramount importance for the construction of systems incorporating mechanical or electrical components built to exacting tolerances, whether such hardware is military or civil. This technology is highly dependent on sensors, positioners, feedback systems, digital computers, and associated components and hardware. Included in the list of metrology equipment are coordinate, linear and angular measurement machines using laser, standard light, photogrammetry, and noncontact techniques. The tolerances of parts measured range from  $\pm 1$  nm (corresponding to an optical surface finish prepared by diamond turning, with ion beam polishing) to  $\pm 10$   $\mu\text{m}$  (corresponding to more traditional metal machining).

**Table 10.3-1. Metrology Militarily Critical Technology Parameters**

| TECHNOLOGY  | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority   | Critical Materials | Unique Test,<br>Production, and<br>Inspection<br>Equipment                   | Unique Software<br>and Parameters | Control<br>Regimes      |
|---|---|--------------------|--|-----------------------------------|-------------------------|
| <b>COMPUTER, NUMERICALLY OR STORED PROGRAM CONTROLLED DIMENSIONAL INSPECTION MACHINES</b> | Computer controlled coordinate-measuring machine (CMM) with both:<br>$\geq 2$ axes; and<br>a one dimensional length measurement uncertainty $\leq (1.25 + L/1,000)$ $\mu\text{m}$ , tested with a probe with an accuracy of $< 0.2$ $\mu\text{m}$ (L is the measured length in mm).                             | None identified    | Laser interferometer measuring equipment with accuracies $< 1$ $\mu\text{m}$ | None identified                   | WA IL Cat 2<br>NDUL 1.3 |
| <b>LINEAR DISPLACEMENT (NON-CONTACT) MEASURING DEVICES</b>                                | Non-contact type with a resolution $\leq 0.2$ $\mu\text{m}$ within a measuring range of 0.2 mm.   | None identified    | None identified  | None identified                   | WA IL Cat 2<br>NDUL 1.3 |
| <b>LINEAR MEASURING MACHINES USING LINEAR VOLTAGE DIFFERENTIAL TRANSFORMER SYSTEMS</b>    | Linearity $\leq 0.1\%$ within a measuring range up to 5 mm; and Drift $\leq 0.1\%$ per day at a standard ambient room temperature $\pm 1$ K.  | None identified    | None identified  | None identified                   | WA IL Cat 2<br>NDUL 1.3 |
| <b>LINEAR MEASURING MACHINES</b>  | Laser, <u>and</u><br>The capability to maintain, for at least 12 hours, over a temperature range of $\pm 1$ K around a standard temperature and pressure, both<br>A resolution $\leq 0.1$ $\mu\text{m}$ over full scale <u>and</u><br>A measurement uncertainty $\leq (0.2 \mu\text{m} + L/2000 \mu\text{m})$ . | None identified    | None identified  | None identified                   | WA IL Cat 2<br>NDUL 1.3 |
| <b>ANGULAR DISPLACEMENT MEASURING DEVICES</b>   | Angular position deviation $\leq 0.00025^\circ$ .   | None identified    | None identified  | None identified                   | WA IL Cat 2<br>NDUL 1.3 |

(Continued)

**Table 10.3-1. Metrology Militarily Critical Technology Parameters (Continued)**

| TECHNOLOGY  | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority  | Critical Materials | Unique Test,<br>Production, and<br>Inspection<br>Equipment                                 | Unique Software<br>and Parameters | Control<br>Regimes    |
|---|--|--------------------|--|-----------------------------------|-----------------------|
| <b>METROLOGY<br/>EQUIPMENT FOR<br/>SPECTRAL<br/>CHARACTERIZATION<br/>OF REFLECTANCE,<br/>TRANSMISSION,<br/>ABSORPTION AND<br/>SCATTER</b> | Capable of measuring<br>reflectance/transmission to<br>better than 50 ppm absolute<br>accuracy or Absorption/scatter<br>to better than 10 ppm.   | None identified    | None identified  | None identified                   | WA IL Cat 2<br>MTCR 9 |
| <b>LASER LOCATION<br/>SYSTEMS</b>   | Automated, laser measuring<br>system that uses optical<br>triangulation to achieve high<br>accuracy of 3 dimensional<br>positions, with<br>The capability to measure<br>≥ 10 points per second.                            | None identified    | None identified  | None identified                   | None                  |
| <b>NON-CONTACT<br/>PROBE<br/>MEASUREMENT<br/>EQUIPMENT</b>  | 5 Angstroms ( $5 \times 10^{-8}$ cm)<br>accuracy   | None identified    | None identified  | None identified                   | MTCR 9                |
| <b>SOLID MODEL<br/>FITTING TECHNIQUE</b>  | An advanced means to<br>evaluate conformance to<br>design. Utilize randomly<br>measured points described by<br>three-dimensional standard<br>coordinates, adjusts for<br>misalignment of model, and<br>reports deviations. | None identified    | Machine tools, very<br>accurate bearings<br>and races, and laser<br>measuring<br>equipment | Solid model<br>fitting software   | None                  |

## SECTION 10.4—NON-DESTRUCTIVE INSPECTION EQUIPMENT

### OVERVIEW

This subsection covers technologies for the non-destructive detection and characterization of flaws, such as cracks, porosity, inclusions, and delaminations, and for the non-destructive measurement or prediction of mechanical properties, such as bond strength or elastic moduli in materials, components, or structures. The technologies also involve the means for interpreting the significance of detected flaws so that an immediate accept/reject decision can be made or incremental changes can be made to correct a flawed or out-of-control process. In many instances, they provide the basis for the design and the determination of reliability and maintenance requirements for military systems, including ordnance, vehicles, ships, submarines, aircraft, and missiles.

**Table 10.4-1. Non-Destructive Inspection Equipment Militarily Critical Technology Parameters**

| TECHNOLOGY  | Militarily Critical Parameters Minimum Level to Assure US Superiority  | Critical Materials | Unique Test, Production, and Inspection Equipment | Unique Software and Parameters           | Control Regimes |
|---|--|--------------------|---|--|-----------------|
| <b>NON-DESTRUCTIVE INSPECTION SYSTEMS CAPABLE OF ADAPTIVE MOTION CONTROL FOR SCANNING COMPONENTS WHOSE NOMINAL ENVELOPE MAY VARY.</b>   | ≥ 2 axes with adaptive control, allowing feedback action and equipped with sensors to allow examination of item to be inspected.   | None identified    | None identified                                   | Special algorithms to control inspection | None            |
| <b>NON-DESTRUCTIVE INSPECTION SYSTEMS IN MORE THAN 4 INTERPOLATING AXES WHICH CAN BE COORDINATED SIMULTANEOUSLY FOR CONTOURING CONTROL</b>  | > 4 interpolating axes that can be coordinated simultaneously for contouring control   | None identified    | None identified                                   | None identified                          | None            |
| <b>COMPUTER-BASED AUTOMATIC INSPECTION EQUIPMENT HAVING DEDICATED CIRCUITRY, HARDWARE AND SOFTWARE FOR AUTOMATIC COLLECTION, REDUCTION, ANALYSIS AND ACCEPT/REJECT CRITERIA, AND CAPABLE OF PROCESSING DATA IN REAL TIME.</b> | Complete hardware/software system to allow control of equipment, as well as performing complete data collection, reduction and analysis, whether in real-time or near real-time. | None identified    | None identified                                   | None identified                          | None            |

## SECTION 10.5—PRODUCTION EQUIPMENT

### OVERVIEW

This subsection addresses machine tools used for the production of military systems and components. The individual machine tools provide the foundation of a manufacturing base. The equipment includes both numerically controlled (NC) and non-NC machines. NC machines are computer controlled so that the motions of the various axes are simultaneously and continually coordinated to maintain a predetermined (programmed) path. This machinery includes turning, milling, and grinding machines, electrical discharge machines (EDM); water and liquid jet machines; and electron beam and laser cutting machines. The non-NC machines include single point diamond cutting and fly-cutting machine tools. Such tools have wide application in the production of optical-quality surfaces.

**Table 10.5-1. Production Equipment Militarily Critical Technology Parameters**

| TECHNOLOGY   | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority   | Critical Materials | Unique Test,<br>Production, and<br>Inspection<br>Equipment | Unique Software<br>and Parameters | Control<br>Regimes      |
|--|---|--------------------|--|-----------------------------------|-------------------------|
| <b>MILLING MACHINE<br/>FOR REMOVING OR<br/>CUTTING METALS,<br/>CERAMICS OR<br/>COMPOSITES</b>  | More than 4 axes which have<br>simultaneous contouring<br>control, including rotary axes.   | None identified    | None identified  | None identified                   | WA IL Cat 2<br>NDUL 1.2 |
| <b>MACHINE TOOLS<br/>FOR REMOVING OR<br/>CUTTING METALS,<br/>CERAMICS OR<br/>COMPOSITES BY<br/>TURNING, GRINDING<br/>OR MILLING</b>                              | Two or more axes which have<br>simultaneous contouring<br>control and either<br>Tilting spindles,<br>Camming > 0.2 $\mu\text{m}$ ,<br>Run-out < 0.2 $\mu\text{m}$ , or<br>Positioning accuracy on any<br>rotary axis < 0.001° | None identified    | None identified  | None identified                   | None                    |
| <b>GRINDING MACHINE<br/>FOR REMOVING OR<br/>CUTTING METALS,<br/>CERAMICS OR<br/>COMPOSITES</b>   | Two or more axes which have<br>simultaneous contouring<br>control and<br>A positioning accuracy < 4 $\mu\text{m}$ .   | None identified    | None identified  | None identified                   | WA IL Cat 2             |
| <b>MACHINE TOOLS<br/>FOR REMOVING OR<br/>CUTTING METALS,<br/>CERAMICS OR<br/>COMPOSITES BY<br/>TURNING OR MILLING</b>  | Two or more axes which have<br>simultaneous contouring<br>control and<br>A positioning accuracy < 6 $\mu\text{m}$ .   | None identified    | None identified  | None identified                   | WA IL Cat 2             |
| <b>ELECTRO<br/>DISCHARGE<br/>MACHINES (EDM) OF<br/>WIRE-FEED TYPE</b>  | Five or more axes for contour<br>control  | None identified    | None identified  | None identified                   | None                    |
| <b>ELECTRO<br/>DISCHARGE<br/>MACHINES (EDM) OF<br/>NONWIRE TYPE</b>  | Two or more rotary axes for<br>contour control  | None identified    | None identified  | None identified                   | WA IL Cat 2<br>NDUL 1.2 |
| <b>MACHINE TOOLS<br/>FOR REMOVING<br/>METALS, CERAMICS<br/>OR COMPOSITES, BY<br/>MEANS OF WATER,<br/>OTHER LIQUID JETS,<br/>ELECTRON BEAM OR<br/>LASER BEAM.</b> | Two or more rotary axes, that<br>can be coordinated<br>simultaneously, and<br>A positioning accuracy of<br>better than 0.003°   | None identified    | None identified  | None identified                   | WA IL Cat 2             |

(Continued)

**Table 10.5-1. Production Equipment Militarily Critical Technology Parameters (Continued)**

| TECHNOLOGY  | Militarily Critical Parameters Minimum Level to Assure US Superiority   | Critical Materials    | Unique Test, Production, and Inspection Equipment | Unique Software and Parameters | Control Regimes |
|---|---|-----------------------|---|--------------------------------|-----------------|
| <b>SPINDLE ASSEMBLIES, CONSISTING OF SPINDLES AND BEARINGS AS A MINIMAL ASSEMBLY, SPECIALLY DESIGNED FOR MACHINE TOOLS DESCRIBED ABOVE.</b> | Run-out or camming < 0.0006 mm (0.6 $\mu$ m) in one revolution of the spindle.  | None identified       | None identified                                   | None identified                | WA IL Cat 2     |
| <b>LINEAR POSITION FEEDBACK UNITS (E.G., INDUCTIVE TYPE DEVICES, GRADUATED SCALES, OR LASER SYSTEMS).</b>                                   | An overall accuracy < [(800 + (600 $\times$ L $\times$ 10 <sup>-3</sup> )] nm, where L is the effective length in mm.   | None identified       | None identified                                   | None identified                | WA IL Cat 2     |
| <b>ROTARY POSITION FEEDBACK UNITS (E.G., INDUCTIVE TYPE DEVICES, GRADUATED SCALES, OR LASER SYSTEMS).</b>                                   | An accuracy < 0.00025°.   | None identified       | None identified                                   | None identified                | WA IL Cat 2     |
| <b>SLIDE WAY ASSEMBLIES CONSISTING OF A MINIMAL ASSEMBLY OF WAYS, BED AND SLIDE.</b>  | Yaw, pitch or roll < 2 sec. of arc TIR total indicator reading; horizontal straightness < 2 $\mu$ m/300 mm length; and vertical straightness < 2 $\mu$ m/300 mm length.   | None identified       | None identified                                   | None identified                | None            |
| <b>SINGLE POINT DIAMOND CUTTING TOOL INSERTS.</b>   | Flawless and chip-free cutting edge when magnified 400 times; Cutting radius from 0.1 to 0.5 mm, inclusive; and Cutting radius out-of-roundness < 0.002 mm TIR.   | Diamond cutting tools | None identified                                   | None identified                | None            |
| <b>NON-NUMERICALLY CONTROLLED MACHINE TOOLS FOR GENERATING OPTICAL QUALITY SURFACE USING A SINGLE POINT CUTTING TOOL.</b>                   | Slide positioning accuracy < .0005 mm/300 mm of travel; Bidirectional slide positioning repeatability < .00025 mm/300 mm of travel; Spindle run-out and camming < .0004 mm; Angular deviation < 2 sec. of arc; and Perpendicularity <.001 mm/300 mm travel. | None identified       | None identified                                   | None identified                | WA IL Cat 2     |
| <b>NON-NUMERICALLY CONTROLLED FLY-CUTTING MACHINE TOOLS FOR GENERATING OPTICAL QUALITY SURFACES</b>   | Spindle run-out and camming < 0.0004 mm TIR; and Angular deviation of slide movement (yaw, pitch and roll) < 2 seconds of arc. TIR, over full travel.   | None identified       | None identified                                   | None identified                | WA IL Cat 2     |

(Continued)

**Table 10.5-1. Production Equipment Militarily Critical Technology Parameters (Continued)**

| TECHNOLOGY   | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority  | Critical Materials | Unique Test,<br>Production, and<br>Inspection<br>Equipment | Unique Software<br>and Parameters   | Control<br>Regimes      |
|--|--|--------------------|--|---|-------------------------|
| <b>MACHINE TOOLS<br/>SPECIALLY<br/>DESIGNED FOR<br/>CUTTING, GRINDING,<br/>HONING AND<br/>FINISHING OF<br/>HARDENED SPUR,<br/>HELICAL AND<br/>DOUBLE HELICAL<br/>GEARS.</b>  | Ability to produce hardened gears ( $R_c \geq 40$ ) with a pitch diameter $> 1,250$ mm and A face width of 15% of pitch diameter, or larger, finished to a quality of AGMA-14, or better (equivalent to ISO 1328 class 3). | None identified    | None identified  | None identified   | WA IL Cat 2             |
| <b>HOT ISOSTATIC<br/>PRESSES</b>   | Chamber cavity whose inside diameter $\geq 406$ mm; a A working pressure $> 204$ MPa; and Thermal environment $> 1,773$ K;   | None identified    | None identified  | None identified   | WA IL Cat 2<br>NDUL 1.5 |
| <b>GRINDING, LAPPING<br/>AND HONING<br/>MACHINES FOR<br/>PRECISION<br/>BEARINGS</b>  | Capable of manufacturing precision bearings with radial run-out of 8 microinches, or better.   | None identified    | None identified  | None identified   | None                    |
| <b>SOFTWARE FOR<br/>NCs/PCs THAT<br/>HAVE <math>\geq 4</math>-AXES<br/>SIMULTANEOUS<br/>CONTOURING<br/>CONTROL.</b>  | The ability to control a machine tool having $\geq 4$ axes, such that the movement on each axis can be simultaneously contour controlled.  | None identified    | None identified  | None identified   | WA IL Cat 2             |
| <b>SOFTWARE FOR<br/>NCs/PCs THAT<br/>HAVE REAL TIME<br/>PROCESSING OF<br/>DATA BY ADAPTIVE<br/>CONTROL WITH<br/>MORE THAN ONE<br/>PHYSICAL VARIABLE<br/>MEASURED AND<br/>PROCESSED BY<br/>MEANS OF A<br/>COMPUTING MODEL<br/>TO CHANGE ONE OR<br/>MORE MACHINING<br/>INSTRUCTIONS.</b> | Ability to modify machining instructions, as a result of measuring $> 1$ variable, and Capable of changing one, or more machining instructions.  | None identified    | None identified  | Software which allows real-time modification of the tool path, feed rate or spindle data. | WA IL Cat 2             |

## SECTION 10.6—ROBOTICS

### OVERVIEW

This subsection covers the technology for the general category of robots, controllers and end-effectors used in conjunction with other manufacturing equipment for the production or testing of critical hardware. Robots can essentially be separated into four distinct disciplines: the robot, the controller (computer), sensors (including cameras), and end effectors (the "gripper"). Robots have found a wide range of applications in manufacturing, including welders, sprayers, assemblers, loaders/unloaders, etc. They have also found use in handling hazardous or radioactive materials, transporting explosive weapons, and performing tasks in space.

**Table 10.6-1. Robotics Militarily Critical Technology Parameters**

| TECHNOLOGY   | Militarily Critical Parameters<br>Minimum Level to Assure US<br>Superiority                     | Critical Materials | Unique Test,<br>Production, and<br>Inspection<br>Equipment   | Unique Software<br>and Parameters | Control<br>Regimes         |
|--|---|--------------------|--|-----------------------------------|----------------------------|
| <b>ROBOTS (DESIGNED<br/>TO OPERATE IN<br/>EXPLOSIVE OR EMP<br/>ENVIRONMENTS),<br/>CONTROLLER AND<br/>END-EFFECTORS</b> | Incorporating protection of<br>hydraulic lines and Using<br>fluids with flash points<br>> 839 K | None identified    | Machine tools,<br>inspection<br>equipment and all<br>necessary<br>equipment to<br>manufacture<br>sensors, etc. | None identified                   | NDUL 1.6(a)                |
| <b>ROBOTS DESIGNED<br/>FOR NUCLEAR<br/>ENVIRONMENTS</b>  | Designed to operate in a<br>radiation environment greater<br>than $5 \times 10^5$ rad (Si)      | None identified    | Machine tools,<br>inspection<br>equipment and all<br>necessary<br>equipment to<br>manufacture<br>sensors, etc. | None identified                   | WA IL Cat 2<br>NDUL 1.6(b) |
| <b>ROBOTS DESIGNED<br/>FOR SPACE<br/>APPLICATIONS</b>  | Designed to operate at<br>altitudes exceeding<br>150 miles.                                     | None identified    | Machine tools,<br>inspection<br>equipment and all<br>necessary<br>equipment to<br>manufacture<br>sensors, etc. | Operational<br>software           | WA IL Cat 2                |